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AMENDMENT UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE –  
EXAMINING GROUP 2877

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PATENT

Attorney Docket No.: 16869P-042900US

Client Ref. No.: 210000749US1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Takenori HIROSE, et al.

Application No.: 10/081,385

Filed: February 20, 2002

For: FILM THICKNESS MEASURING  
METHOD AND APPARATUS, AND THIN  
FILM DEVICE MANUFACTURING  
METHOD AND MANUFACTURING  
APPARATUS USING SAME

Customer No.: 20350

Confirmation No. 9702

Examiner: Hwa S. Lee

Technology Center/Art Unit: 2877

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**Mail Stop AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

July 22, 2005

Sir:

In response to the Final Office Action mailed March 9, 2005 on the above-referenced application, for which a **Petition to Extend Time** for two months is enclosed, please enter the following amendments and remarks:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.

**Enclosures** include a Petition under 37 CFR 1.78(a)(3) and a Statement under 37 CFR 1.78(a)(3) following page 13 of this paper.